03560.002998



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: YUKIKO IWASAKI ET AL. Application No.: 10/083,585) : Examiner: Not Yet Known		
)		
		: Group Art Unit: 2812		
Filed: F	February 27, 2002)		
For:	METHOD FOR MANUFACTURING A SEMICONDUCTOR FILM	:) :) June 18, 2002	JUN 2	REC
Commissioner for Patents Washington, D.C. 20231				CEIVED
	INFORMATION DI	SCLOSURE STATEMENT	4 2002 CENTER 2800,	

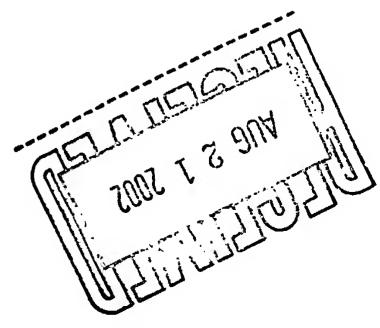
Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are enclosed.

The Examiner's attention is also directed to the following U.S. Applications:

APPLICATION NO.	FILING DATE	GROUP ART UNIT
09/346,678	7/2/99	2815
09/592,559	6/12/00	2825

Copies of the cited Applications are also enclosed.



CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicants

Registration No. __

FITZPATRICK, CELLA, HARPER & SCINTO

30 Rockefeller Plaza

New York, New York 10112-3801

Facsimile: (212) 218-2200